Form PTO-1449

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OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)													
GSE		1	Takeshi MASAKI, "Micro Electro Discharge Machining Technologies", National Technical Report, Vol. 39, No. 5, Oct. 1993.										
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EXAMINER	2	lea	they SEvans DATE CONSIDERED June 1, 2003										

*EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.